

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): ZAIT, Eitan                      Examiner: FRASER, Stewart A.  
Serial No.: 10/564,972                      Group Art Unit: 1795  
Filed: August 1, 2006                      Confirmation No.: 7182  
Title: METHOD FOR CORRECTING CRITICAL DIMENSION VARIATIONS IN PHOTOMASKS

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**AMENDMENT**

**Mail Stop Amendment**  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment is filed in response to the Office Action dated January 7, 2009 issued by the United States Patent and Trademark Office in connection with the above-identified Application. A response to the January 7, 2009 Office Action was due April 7, 2009. Applicants are concurrently filing a Petition for a One-Month Extension of Time, including the required fee. Therefore, a response is due May 7, 2009. Accordingly, this Amendment is being timely filed.

Kindly amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.